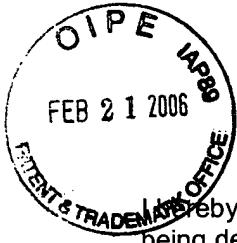


FW

PATENT APPLICATION



CERTIFICATE OF MAILING/FACSIMILE TRANSMISSION (37 CFR 1.8)

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Maria T. Sanchez
(Print Name)

Date: February 16, 2006

Maria T. Sanchez
(Signature)

Docket No. 2003JP314

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Tatsuro NAGAHARA et al. ✓ Art Unit: To Be Assigned

Serial No. 10/564,997, filed January 13, 2006 Examiner: To be Assigned

For: **DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND
METHOD FOR FORMING PATTERNED RESIST FILM**

**INFORMATION DISCLOSURE STATEMENT WITHIN THREE MONTHS OF FILING
OR BEFORE MAILING OF THE FIRST OFFICE ACTION
(37 CFR 1.97 (b))**

February 16, 2006

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Serial No.: 10/564,997
Filed: January 13, 2006

Dear Sir:

1. IDENTIFICATION OF TIME OF FILING INFORMATION DISCLOSURE STATEMENT

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office action on the merits, whichever event occurs last. 37 CFR 1.97(b).

2. PRELIMINARY STATEMENTS

Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

Pursuant to the notice in the Official Gazette notice of 5 August 2003, 1276 O.G. 55, copies of US Patents and/or US Patent Publications are not being enclosed as the present application has a filing date after June 30, 2003.

3. COMPLETED FORM PTO-1449 IS ATTACHED.

4. IDENTIFICATION OF PRIOR APPLICATION IN WHICH LISTED INFORMATION WAS ALREADY CITED AND FOR WHICH NO COPIES ARE SUBMITTED OR NEED BE SUBMITTED

[] This application relies, under 35 U.S.C. 120, on the earlier filing date of prior application Serial No. _____ filed on _____.

5. COPIES OF LISTED INFORMATION ITEMS ACCOMPANYING THIS STATEMENT

US 5,468,494	JP 5-88373
US 5,900,352	JP 2000-181069
US 5,994,031	JP 2001-288270
US 2002/0055066	JP 2002-311591
US 2003/0113657	JP 2002-72502
US 2004/0081912	JP 2002-72504

English Language Abstract of JP 5-088373
English Language Abstract of JP 7-234522
English Language Abstract of JP 11-295899
English Language Abstract of JP 2000-1818069
English Language Abstract of JP 2001-288270
English Language Abstract of JP 2002-229219
English Language Abstract of JP 2002-311591
English Language Abstract of JP 2002-351091
English Language Abstract of JP 2002-72502
English Language Abstract of JP 2002-72504
English Language Abstract of JP 2003-114537
English Language Abstract of JP 2003-131396
English Language Abstract of JP 2003-167329
English Language Abstract of JP 2003-195518
English Language Abstract of JP 2003-295469
English Language Abstract of JP 2003-5382
English Language Abstract of JP 2004-109442
English Language Abstract of JP 2004-126266
English Language Abstract of JP 2004-86180

Machine Language English Translation from JPO of JP 5-88373
Machine Language English Translation from JPO of JP 2000-181069
Machine Language English Translation from JPO of JP 2001-288270
Machine Language English Translation from JPO of JP 2002-311591
Machine Language English Translation from JPO of JP 2002-72502
Machine Language English Translation from JPO of 2002-72504
Machine Language English Translation from JPO of JP 2003-295469
Machine Language English Translation from JPO of JP 2004-109442
Machine Language English Translation from JPO of JP 2004-126266
Machine Language English Translation from JPO of JP 2004-86180

Legible copies of all items listed accompany this information statement except as noted herein.

Pursuant to the Official Gazette notice of 5 August 2003, 1276 O.G. 55, since this application entered the National Stage under 35 USC 371 after June 30, 2003, applicant is not enclosing copies of the above mentioned U.S. patents and/or U.S. patent publications.

[] Items in prior application from which an earlier filing date is claimed for this application as identified in No. 4 above.

6. TRANSLATION(S) OF NON-ENGLISH LANGUAGE DOCUMENTS

[X] Submitted herewith is an English language abstract of the following foreign language patents, publications or information or of those portions of those patents, publications or information considered to be material:

English Language Abstract of JP 5-088373
English Language Abstract of JP 7-234522
English Language Abstract of JP 11-295899
English Language Abstract of JP 2000-1818069
English Language Abstract of JP 2001-288270
English Language Abstract of JP 2002-229219
English Language Abstract of JP 2002-311591
English Language Abstract of JP 2002-351091
English Language Abstract of JP 2002-72502
English Language Abstract of JP 2002-72504
English Language Abstract of JP 2003-5382
English Language Abstract of JP 2003-114537
English Language Abstract of JP 2003-131396
English Language Abstract of JP 2003-167329
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English Language Abstract of JP 2003-295469
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English Language Abstract of JP 2004-126266
English Language Abstract of JP 2004-86180

Machine Language English Translation from JPO of JP 5-88373
Machine Language English Translation from JPO of JP 2000-181069
Machine Language English Translation from JPO of JP 2001-288270
Machine Language English Translation from JPO of JP 2002-311591
Machine Language English Translation from JPO of JP 2002-72502
Machine Language English Translation from JPO of 2002-72504
Machine Language English Translation from JPO of JP 2003-295469
Machine Language English Translation from JPO of JP 2004-109442
Machine Language English Translation from JPO of JP 2004-126266
Machine Language English Translation from JPO of JP 2004-86180

[X] No English language translations of the foreign language patents, publications or information or parts thereof are readily available, except those listed above.

[X] The following foreign language documents submitted are believed to be the equivalent or substantial equivalent of the English language documents identified below, which are also submitted herewith:

Serial No.: 10/564,997
Filed: January 13, 2006

US 2003/0113657 is equivalent to JP 2002-72502 and JP 2002-72504
US 2004/0081912 is equivalent to JP 2000-181069

Pursuant to the Official Gazette notice of 5 August 2003, 1276 O.G. 55, since this application entered the National Stage under 35 USC 371 after June 30, 2003, applicant is not enclosing copies of the above mentioned U.S. patents and/or U.S. patent publications.

Copies of JP 7-234522, JP 11-295899, JP 2002-229219, JP 2002-351091, JP 2003-114537, JP 2003-131396, JP 2003-167329, JP 2003-195518, JP 2003-295469, JP 2003-5382, JP 2004-109442, JP 2004-126266, and JP 2004-86180 are not enclosed as they were cited in the International Search Report submitted with applicants' National Stage filing.

8. IDENTIFICATION OF PERSON(S) MAKING THIS INFORMATION
DISCLOSURE STATEMENT

The person making this statement is the attorney who signs below on the basis of the information in the attorney's file.

Respectfully submitted:



Attorney for Applicant(s)
Sangya Jain
(Reg. No. 38, 504)
AZ Electronic Materials USA Corp.
70 Meister Avenue
Somerville, New Jersey 08876
Telephone: (908) 429-3536
Telefax: (908) 429-3650

Customer No. 26,289

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.
10/564,997Filing Date
FEB 21 2006 (January 13, 2006)Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNEDE RESIST FILM**I hereby certify that this Information Disclosure Citation - 4 Pages*(Identify type of correspondence)*

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February 16, 2006*(Date)***MARIA T. SANCHEZ***(Typed or Printed Name of Person Mailing Correspondence)*
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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>			ATTY DOCKET NO. 2003JP314		SERIAL NO. 10/564,997		
			Tatsuro NAGAHARA et al.				
			FILING January 13, 2006	GROUP To Be Assigned			
U.S. PATENT DOCUMENTS							
EXAMINER INITIALS & TRADEMARK OFFICE	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	5,468,594	11/21/1995	Suzuki et al.				
	5,900,352	5/4/1999	Elsaesser et al.				
	5,994,031	11/30/1999	Hirai et al.				
	2002/0055066	5/9/2002	Takamiya				
	2003/0113657	6/19/2003	Nagahara et al.				
	2004/0081912	4/29/2004	Nagahara et al.				
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	JP 5-88373	4/9/1993	JAPAN			<input checked="" type="checkbox"/>	
	JP 2000-181069	6/30/2000	JAPAN			<input checked="" type="checkbox"/>	
	JP 2001-288270	10/16/2001	JAPAN			<input checked="" type="checkbox"/>	
	JP 2002-72502	3/12/2002	JAPAN			<input checked="" type="checkbox"/>	
	JP 2002-72504	3/12/2002	JAPAN			<input checked="" type="checkbox"/>	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
		English Language Abstract of JP 5-88373.					
		English Language Abstract of JP 7-234522.					
EXAMINER			DATE CONSIDERED				
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional) 2003JP314	Application Number 10/564,997
Applicant(s) Tatsuro NAGAHARA et al.	
Filing Date January 13, 2006	Group Art Unit To Be Assigned

*EXAMINER
INITIAL

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	English Language Abstract of JP 11-295899.
	English Language Abstract of JP 2000-181069.
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	English Language Abstract of JP 2002-229219.
	English Language Abstract of JP 2002-351091.
	English Language Abstract of JP 2002-72502.
	English Language Abstract of JP 2002-72504.
	English Language Abstract of JP 2003-114537.
	English Language Abstract of JP 2003-131396.
	English Language Abstract of JP 2003-167329.
	English Language Abstract of JP 2003-195518.
	English Language Abstract of JP 2003-295469.

EXAMINER

DATE CONSIDERED

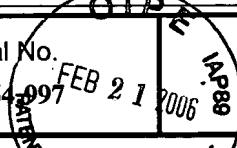
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>		Docket Number (Optional) 2003JP314	Application Number 10/564,997
		Applicant(s) Tatsuro NAGAHARA et al.	
		Filing Date January 13, 2006	Group Art Unit To Be Assigned
*EXAMINER INITIAL	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
	English Language Abstract of JP 2003-5382.		
	English Language Abstract of JP 2004-126266.		
	English Language Abstract of JP 2004-86180.		
	English Language Abstract of JP 2004-109442.		
	Machine English Language Translation from JPO of JP 2003-295469.		
	Machine English Language Translation from JPO of JP 2004-109442.		
	Machine English Language Translation from JPO of JP 2004-126266.		
	Machine English Language Translation from JPO of JP 2004-86180.		
EXAMINER	DATE CONSIDERED		

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al**

Docket No.

2003JP314Serial No.
10/564,997Filing Date
January 13, 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTORESISTIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED RESIST FILM**I hereby certify that this **JP 5-88373 - 4 Pages***(Identify type of correspondence)*

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

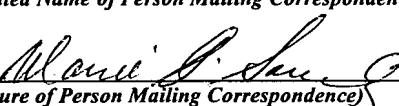
Serial No.
10/564,997FEB 21 2006
January 13, 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTORESISTIVE COMPOSITION AND METHOD FOR FORMING
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I hereby certify that this Machine English Language Translation from JPO of JP 5-88373 - 5 Pages
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Docket No.

2003JP314Serial No.
10/564,997

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To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNEDE POLYESTER FILM**I hereby certify that this **JP 2000-181069 - 15 Pages***(Identify type of correspondence)*

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Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

2003JP314

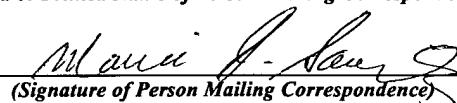
Serial No.
10/564,997Filing Date
FEB 21 2006Examiner
To Be AssignedGroup Art Unit
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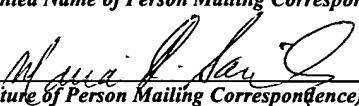
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Docket No.

2003JP314Serial No.
10/564,997Mailing Date
FEB 21 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
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Applicant(s): Tatsuro NAGAHARA et al.

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2003JP314

Serial No.
10/564,997

FEB

Filing Date
January 13, 2006Examiner
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PATTERNEDE RESIST FILM**

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MARIA T. SANCHEZ

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Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

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10/564,997Filing Date
January 13, 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNEDE RESIST FILM**I hereby certify that this JP 2002-72504 - 11 Pages*(Identify type of correspondence)*

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Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.

10/564,997

Filing Date

January 13, 2006

Examiner

To Be Assigned

Group Art Unit

To Be Assigned

Invention: **DEVELOPING SOLUTION FOR PHOTORESISTIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**

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(Identify type of correspondence)

is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The
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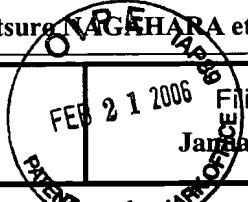
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Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.
10/564,997Filing Date
January 13, 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING AGENT SOLUTION FOR PHOTORESISTIVE COMPOSITION AND METHOD FOR FORMING PATTERNED RESIST FILM**I hereby certify that this JP 2002-311591 - 21 Pages*(Identify type of correspondence)*

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MARIA T. SANCHEZ
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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al.**

Docket No.

2003JP314Serial No.
10/564,997Mailing Date
FEB 21 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTORESISTIVE COMPOSITION AND METHOD FOR FORMING
PATTERNEDE RESIST FILM**

I hereby certify that this **Machine English Language Translation from JPO of JP 2002-311591 - 34 Pages**
(Identify type of correspondence)

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Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on **February 16, 2006**
(Date)

MARIA T. SANCHEZ*(Typed or Printed Name of Person Mailing Correspondence)*
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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)

Applicant(s): Tatsuro NAGAHARA et al

Docket No.

2003JP314

Serial No.
10/564,997Filing Date
21 January 13, 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
PATTERNED POLYIMIDE FILM**I hereby certify that this English Language Abstract of JP 5-88373 - 2 Pages
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Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on February 16, 2006
(Date)**MARIA T. SANCHEZ**

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PATTERNEDE RESIST FILM**I hereby certify that this English Language Abstract of JP 7-234522 - 2 Pages
(Identify type of correspondence)is being deposited with the United States Postal Service as first class mail in an envelope addressed to: The
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(Date)**MARIA T. SANCHEZ**

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I hereby certify that this **English Language Abstract of JP 2002-311591 - 2 Pages**
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Commissioner of Patents and Trademarks, Washington, D.C. 20231-0001 on **February 16, 2006**
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2003JP314

Serial No.
10/564,997

FEB 21 2006

Filing Date
January 13, 2006Examiner
To Be AssignedGroup Art Unit
To Be AssignedInvention: **DEVELOPING SOLUTION FOR PHOTORESISTIVE COMPOSITION AND METHOD FOR FORMING
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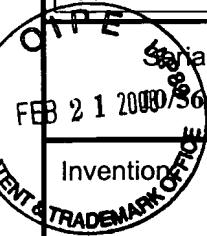
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Docket No.

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Docket No.

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Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

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Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

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Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

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Inventor:

DEVELOPING SOLUTION FOR PHOTOSENSITIVE COMPOSITION AND METHOD FOR FORMING
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Docket No.

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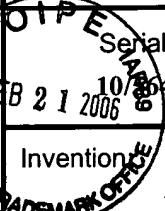
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Docket No.

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Docket No.

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Applicant(s): Tatsuro NAGAHARA et al.

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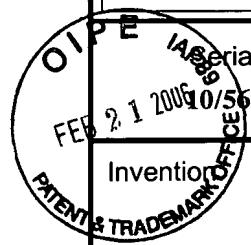
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Docket No.

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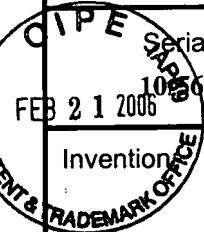
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Applicant(s): Tatsuro NAGAHARA et al.

Docket No.

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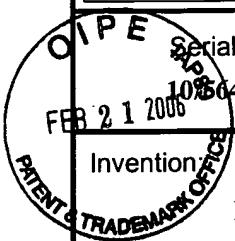
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Docket No.

2003JP314

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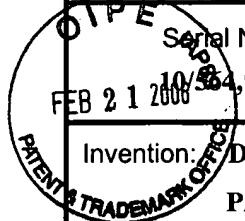
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Invention

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Tatsuro NAGAHARA et al.**

Docket No.

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TRADEMARK**DEVELOPING SOLUTION FOR PHOTORESISTIVE COMPOSITION AND METHOD FOR FORMING
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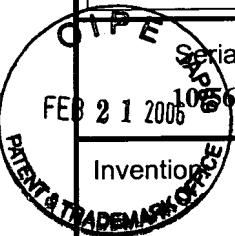
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